

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Judy H. Huang §

Serial No. 09/270,039 §

Filed: APR 26 1999 March 16, 1999 §

For: *Situ* Deposition of A Low K Dielectric Layer, Barrier Layer, Etch Stop, and Anti-Reflective Coating for Damascene Application §

Group Art Unit: Unknown

Examiner: Unknown

| CERTIFICATE OF MAILING<br>37 C.F.R. 1.8  |   |
|--|---|
| I hereby certify that this correspondence is being deposited on <u>4/22</u> , 1999, in the U. S. Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D. C. 20231. |   |
| <u>4/22/99</u><br>Date   | <u>D. Brit Nelson</u><br>D. Brit Nelson |

Assistant Commissioner of Patents  
Washington, D.C. 20231

Sir:

**PRELIMINARY AMENDMENT**

Prior to examination of the above referenced application, the Applicants request that the application be amended as follows:

**In the specification:**

Please change all "cm<sup>2</sup>" references to --"in<sup>2</sup>-- at the following locations:

Page 17, Table 2; row 6, column 1;

Page 17, lines 17 and 18; and

Page 20, line 14.

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**In the claims:**

Please change all "centimeter" references to "inch" at the following locations:

Claim 9, line 6.